

MAP 2013

The 13th International Workshop on Microelectronics Assembling and Packaging

Program Overview

Date: 7th November, 2013/ Venue: Takakura Hotel, Fukuoka

10:20 ~ 10:30	Opening Remark	Poster Exhibition
10:30 ~ 12:30	Session 1: Invited Talks	
12:30 ~ 13:30	Lunch Break	
13:30 ~ 15:10	Session 2: Packaging Supply Chain	
15:10 ~ 15:30	Break	
15:30 ~ 17:10	Session 3: 3D Integration Technology	
17:10 ~ 17:30	Break	
17:30 ~ 18:20	Session 4: Vietnam Session	
18:30 ~ 20:00	Session 5: Poster Session (Reception Party)	

MAP2013 Program

Thursday 7th, November

10:20~10:30 Opening Remark

Hajime Tomokage
Fukuoka University(JAPAN)

10:30~12:30 Session 1: Invited Talks

Chair: Kiyoshi Arita

Panasonic Factory Solutions Co., Ltd.(JAPAN)

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|-------------|-----|--|
| 10:30-11:10 | 1-1 | Research & development of semiconductor devices for space applications
Hiroyuki Shindo
<i>Japan Aerospace Exploration Agency (JAPAN)</i> |
| 11:10-11:50 | 1-2 | 3D packaging technology enabling next generation devices
Mark Gerber
<i>Texas Instruments Incorporated (U.S.A.)</i> |
| 11:50-12:30 | 1-3 | Embedded and stacking technology in ITRI (tentative)
Wei-Chung Lo
<i>Industrial Technology Research Institute (TAIWAN)</i> |

12:30 ~ 13:30	Lunch Break
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13:30~15:10 Session 2: Packaging Supply Chain

Chair: Hisao Kasuga

International Standardization – Innovation Technology Research Association (INOTEK) (JAPAN)

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| 13:30-13:50 | 2-1 | LSI turnkey network business
Hiroyuki Kataoka
<i>Hibikino System-Lab Inc. (JAPAN)</i> |
| 13:50-14:10 | 2-2 | Cu balls and Cu-core balls for 3D packaging
Hiroyoshi Kawasaki
<i>Senju Metal Industry Co., Ltd. (JAPAN)</i> |
| 14:10-14:30 | 2-3 | Proposing “high current handling PCB”, an effective solution for heat countermeasure of semiconductor -introduction to advanced technology supporting emerging power semiconductors-
Manabu Mizuo
<i>TAIYO KOGYO CO., LTD.</i> |
| 14:30-14:50 | 2-4 | SAMURAI CSP provider
Jake Shibata
<i>Tera Probe, Inc. (JAPAN)</i> |
| 14:50-15:10 | 2-5 | On achieving capture power safety in at-speed scan-based logic BIST
Akihiro Tomita
<i>Kyushu Institute of Technology(JAPAN)</i> |

15:10-15:30	Break
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15:30-17:10 Session 3: 3D Integration Technology

Chair: Hajime Tomokage

Fukuoka University(JAPAN)

- 15:30-15:50 3-1 Updated status on embedding device technology in international standardization (IEC/TC91: electronics assembly)
Hisao Kasuga
International Standardization – Innovation Technology Research Association (INOTEK) (JAPAN)
- 15:50-16:10 3-2 The technology of CR-8000 for device embedded substrate
Hirohiko Matsuzawa
Zuken Inc. (JAPAN)
- 16:10-16:30 3-3 Parts mounting system for manufacturing PCBs with embedded components using FUJIKO
Hiroyuki Ao
Fuji Machine Mfg. Co., Ltd.(JAPAN)
- 16:30-16:50 3-4 T Through Silicon Via Process Using DRIE and Cathode PE-CVD
Tomoyuki Nonaka
SAMCO Inc. (JAPAN)
- 16:50-17:10 3-5 High thermal conductive inter chip fill for 3D-IC through pre-applied joining
Yasuhiro Kawase
Mitsubishi Chemical Corporation (JAPAN)

17:10-17:30 Break

17:30-18:20 Session 4: Vietnam Session

Chair: Daisuke Yoshimitsu

SangyoTimes Inc.(JAPAN)

- 17:30-18:00 4-1 Introduction to the program “Development of integrated circuit industry of Ho Chi Minh City (tentative)
Hoang Ngo Duc
Vietnam National University Integrated Circuit Design Research and Education Center (Vietnam)
- 18:00-18:20 4-2 Collaboration between Vietnam national university with Kyushu institute of technology in terms of semiconductor fabrication and Wi-Fi chip design
Hiroshi Ochi
Kyushu Institute of Technology (JAPAN)

18:30~20:00 Poster session; Reception Party

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|-------------------------------------|---------------------------------|
| 5-1 DENKEN Co., Ltd. | 5-2 ALPHA DESIGN Co., Ltd. |
| 5-3 Hibikino System-Lab Inc. | 5-4 SAGA ELECTRONICS Co., Ltd. |
| 5-5 FUKUDEN SHIZAI K.K. | 5-6 Keirex Technology Inc. |
| 5-7 YDC Corporation | 5-8 Zuken Inc. |
| 5-9 FUJI MACHINE MFG. Co., Ltd. | 5-10 Noda Screen Co., Ltd. |
| 5-11 WALTERS Co., Ltd. | 5-12 Hitachi Chemical Co., Ltd. |
| 5-13 Senju Metal Industry Co., Ltd. | 5-14 TAIYO KOGYO Corporation |
| 5-15 SAMCO Inc. | 5-16 PMT CORPORATION |
| 5-17 Tera Probe, Inc. | 5-18 OMRON Corporation |
| 5-19 Kyushu Institute of Technology | 5-20 Ellia Co., Ltd. |

MAP2013 参加申込用紙

必要事項をご記入の上、アジア半導体機構事務局（担当：古賀）、FAX(092-721-4904)へファックスもしくはE-mail(astsa@kerc.or.jp)でお送り下さい。折り返し、ご請求書をお送りします

氏名

会社名

部署・役職

住所 〒

E-mail

電話

Fax

ご不明な点ございましたら、下記まで御連絡下さい。

アジア半導体機構(ASTSA) 担当: 古賀、中川
Tel: 092-721-4907
Fax: 092-721-4904 E-mail: astsa@kerc.or.jp

---開催場所にご注意下さい---

開催場所が変更となりましたので、ご注意ください。

MAP2013

会期:2013年11月7日(木) 10:20~18:00

会場:タカラホテル福岡

福岡市中央区渡辺通 2-7-21

最寄り駅:福岡市営地下鉄 渡辺通駅 徒歩5分

西鉄薬院駅 徒歩5分



Google Map

---お問い合わせ先---

MAP2013

MAP2013 実行委員会事務局(財団法人九州経済調査協会内)

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